



Docket 49481
IN THE UNITED STATES PATENT OFFICE

In re applications: Hatanaka

Group: 2877

Serial # 09/471,829

Examiner N/A

Filed 12/23/99

For: thickness measurement apparatus of thin
film using light interface method

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

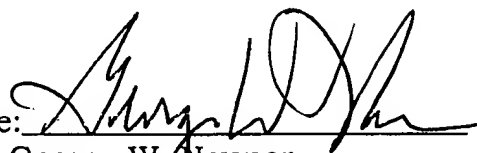
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Applicant requests that all further communications from the Patent and Trademark Office in
connection with the subject application be sent to the following address:

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